

<b>Notice of References Cited</b>	Application/Control No. 10/742,896	Applicant(s)/Patent Under Reexamination HARANO ET AL.	
	Examiner Laura M. Schillinger	Art Unit 2813	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0135143	07-2004	Harano et al.	257/057
*	B	US-5,061,985	10-1991	Meguro et al.	257/751
*	C	US-6,207,481	03-2001	Yi et al.	438/166
*	D	US-6,833,883 B2	12-2004	Park et al.	349/43
*	E	US-6,664,149 B2	12-2003	Shih, Hsueh-Feng	438/151
*	F	US-6,573,134 B2	06-2003	Ma et al.	438/216
*	G	US-6,509,614 B1	01-2003	Shih, Hsueh-Feng	257/350
*	H	US-6,362,028 B1	03-2002	Chen et al.	438/149
*	I	US-6,355,956 B1	03-2002	Kim, Kee-Jong	257/347
*	J	US-6,355,510 B1	03-2002	Kim, Kee-Jong	438/149
*	K	US-5,716,871 A	02-1998	Yamazaki et al.	438/635
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.